

Electronic Patent Application Fee Transmittal

Application Number:		10660813		
Filing Date:		12-Sep-2003		
Title of Invention:		Reactive ion etching for semiconductor device feature topography modification		
First Named Inventor/Applicant Name:		Hemant P. Mungekar		
Filer:		Jason A. Sanders/Janet Newmaker		
Attorney Docket Number:		A7600P1/T51700		
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Filing a brief in support of an appeal	1402	1	510	510
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				510